(Amended). A method of manufacturing a self-light-emitting device according to claim 6, wherein said application liquid is pushed out from said nozzle in accordance with pressurization, and is applied.

11 (Amended). A method of manufacturing a self-light-emitting device according to claim 6, wherein said application liquid is pushed out from said nozzle in accordance with a medium selected from a group consisting of capillary action, the weight of said application liquid, and pressure; and is applied.

12 (Amended). A method of manufacturing a self-light-emitting device according to claim 6, wherein said application liquid filling said nozzle is applied in accordance with a contact element of said nozzle contacting a bank.

Please add the following new claims:

13. (New) A method of manufacturing a self-light-emitting device, comprising the steps of: forming particles of an application liquid in a nozzle by applying an ultrasonic oscillation to the application liquid;

applying electric voltage to the particles for forming charged particles; applying electric voltage to the charged particles for accelerating the charged particles;

applying electric voltage to the accelerated charged particles for controlling a flow of the accelerated charged particles.

14. (New) A method of manufacturing a self-light-emitting device, comprising the steps of: forming particles of an application liquid in a nozzle by applying an ultrasonic oscillation and heat to the application liquid;

applying electric voltage to the particles for forming charged particles;

applying electric voltage to the charged particles for accelerating the charged particles;

applying electric voltage to the accelerated charged particles for controlling a flow of the accelerated charged particles.

- 15. (New) A method of manufacturing a self-light-emitting device according to claim 13, wherein the application liquid comprises at least a highly conductive solvent.
- 16. (New) A method of manufacturing a self-light-emitting device according to claim 14, wherein the application liquid comprises at least a highly conductive solvent.
- 17. (New) A method of manufacturing a self-light-emitting device according to claim 13, wherein the highly conductive solvent is toluene or N-methylpiloridon.
- 18. (New) A method of manufacturing a self-light-emitting device according to claim 14. wherein the highly conductive solvent is toluene or N-methylpiloridon.